

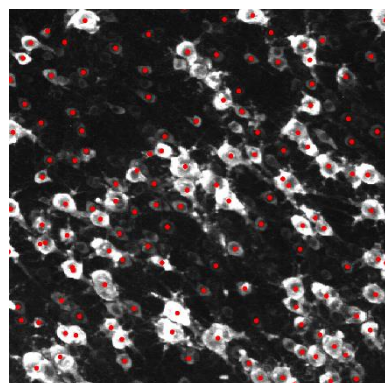
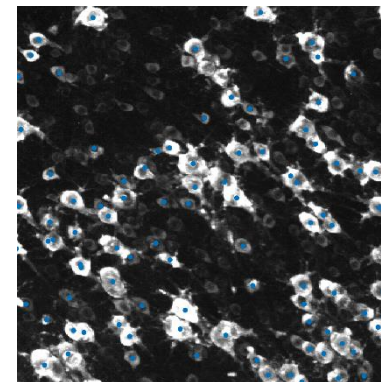
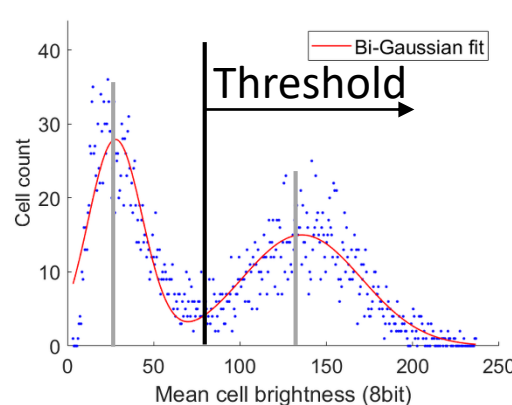
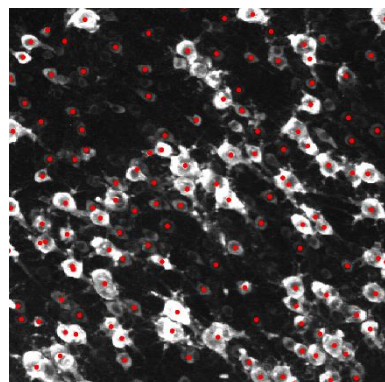
Two-photon
stack recording

CellPose mask
training

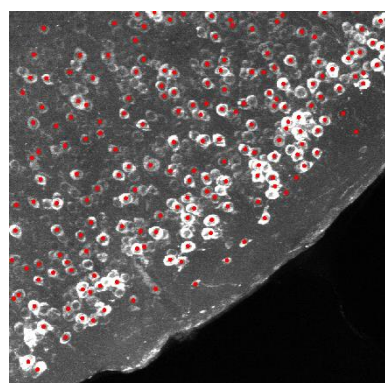
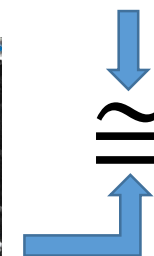
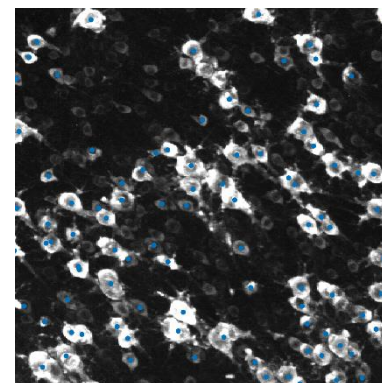
Stitching

Max-projection

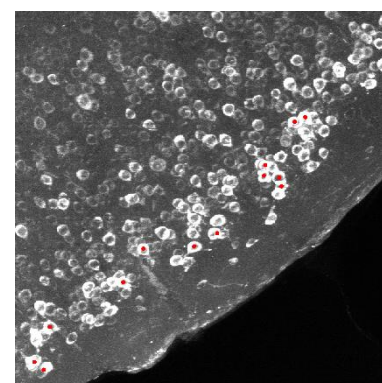
Global contrast



Threshold
3*Background
intensity (L1)



Threshold
3*Background
intensity (L1)



~ 2-3%